## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
••	:	Examiner: P.H. Patel
AKIHIRO KIMURA ET AL.	)	
	:	Group Art Unit: 2829
Application No.: Division	)	•
of U.S. Patent Appln.	:	
No. 10/143,783	)	
•	:	
Filed: Herewith	)	
	:	
For: VOLTAGE-APPLYING PROBE,	)	
APPARATUS FOR MANUFAC-	:	
TURING ELECTRON SOURCE	)	
USING THE PROBE, AND	:	
METHOD FOR MANUFACTURING	)	
ELECTRON SOURCE USING	:	
THE APPARATUS	)	February 27, 2004
Mail Stop		
Commissioner for Patents		
P.O. Box 1450		
Alexandria, VA 22313-1450		

## PRELIMINARY AMENDMENT, CLAIM TO PRIORITY AND INFORMATION DISCLOSURE STATEMENT

Sir:

Preliminary to examination, please amend the above-identified application, filed herewith, as follows.